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CONFIRMATION NO. 4530

SERIAL NUMBER 10/035,773	FILING DATE 12/21/2001 RULE	CLASS 204	GROUP ART UNIT 1745	ATTORNEY DOCKET NO. M-5091-2P US	
APPLICANTS George D. Papasouliotis, Cupertino, CA; Robert D. Tas, Morgan Hill, CA; Patrick A. Van Cleemput, Sunnyvale, CA; Bart van Schravendijk, Sunnyvale, CA;					
** CONTINUING DATA ***** THIS APPLICATION IS A CIP OF 09/053,554 04/01/1998					
** FOREIGN APPLICATIONS ***** <i>none</i>					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/14/2002					
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>Tom Chen</i> Examiner's Signature _____ Initials _____		STATE OR COUNTRY CA	SHEETS DRAWING 2	TOTAL CLAIMS 35	INDEPENDENT CLAIMS 3
ADDRESS Tom Chen SKJERVEN MORRILL MacPHERSON LLP Suite 300 610 Newport Center Drive Newport Beach, CA 92660					
TITLE Process for depositing F-doped silica glass in high aspect ratio structures					
FILING FEE RECEIVED 1010	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		